L	Hits	Search Text	DB	Time stamp
Number -	68	(plasma adj generators!) and 118/\$4.ccls.	IICDAM.	2002/12/04
		(Prasma ad) generators:) and 110/54.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT;	2002/12/04
-	5	(plasma adj generators!) and 117/\$4.ccls.	IBM_TDB USPAT; US-PGPUB; EPO; JPO; DERWENT;	2002/12/04 13:19
-	3	(ECR near2 (several or plural\$4 or multiple or second)) and 117/\$4.ccls.	IBM_TDB USPAT; US-PGPUB; EPO; JPO; DERWENT;	2002/12/04 13:23
-	78	(ald or ale or sequential adj (chemical adj vapor or CVD)) and (117/\$4.ccls. or 118/\$4.ccls.) and plasma	IBM_TDB USPAT; US-PGPUB; EPO; JPO; DERWENT;	2002/12/04 14:02
-	113	plasma adj (ald oe ale or atomic adj layer or sequential adj chemical or sequential adj CVD)	IBM_TDB USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/12/04 14:00
-	10	plasma adj (ald or ale or atomic adj layer or sequential adj chemical or sequential adj CVD)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/12/04 14:00
_	42	(ald or ale or sequential adj (chemical adj vapor or CVD)) same plasma and (117/\$4.ccls.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/12/04 14:23
	80	(ald or ale or sequential adj (chemical adj vapor or CVD)) same apparatus and (422/\$4.ccls. or 427/\$4.ccls. or 118/\$4.ccls.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/12/04 14:47
. <del>-</del>	30	(ald or ale or sequential adj (chemical adj vapor or CVD)) same apparatus and (422/\$4.ccls. or 427/\$4.ccls. or 118/\$4.ccls.) and (supply or precursor or reactant) near4 control\$5	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/12/04 14:49
-	30	(ald or ale or sequential adj (chemical adj vapor or CVD)) same apparatus and (422/\$4.ccls. or 427/\$4.ccls. or 118/\$4.ccls.) and (supply or precursor or reactant) near4 control\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/12/04 15:06
-	114	(plasma adj generat\$4 or ECR) near3 two and (118/\$4.ccls. or 422/\$4.ccls. or 427/\$4.ccls.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/12/04 15:26
-	102	(plasma adj generat\$4 or ECR) near3 remote and (118/\$4.ccls. or 422/\$4.ccls. or 427/\$4.ccls.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/12/04 15:51
-	105	(plasma adj generat\$4 or ECR) near3 (separate or individual) and (118/\$4.ccls. or 422/\$4.ccls. or 427/\$4.ccls.)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM TDB	2002/12/04

_	35	[ 2] t 2 m 2 h 2 1		
1	35	alternately adj suppl\$4 and (ale or ald)	USPAT;	2002/12/04
			US-PGPUB;	17:08
			EPO; JPO;	
			DERWENT;	1
			IBM_TDB	
_	19	sequential\$4 adj (CVD or chemical adj	USPAT;	2002/12/04
ľ		vapor) and (118/\$4.ccls. or 422/\$4.ccls.)	US-PGPUB;	16:31
			EPO; JPO;	1
			DERWENT;	
			IBM TDB	
i -	10	i and the same of and same same of and	USPAT;	2002/12/06
		and (118/\$4.ccls. or 422/\$4.ccls.)	US-PGPUB;	11:19
			EPO; JPO;	
			DERWENT;	
			IBM TDB	
-	51	(plasma same activat\$4 same deposit\$4)	USPAT;	2002/12/06
		and (117/\$4.ccls.)	US-PGPUB;	13:31
			EPO; JPO;	
			DERWENT;	
			IBM TDB	
-	56	(plasma same activat\$4 same temperature)	USPAT;	2002/12/06
		and (117/\$4.ccls.)	US-PGPUB;	13:38
1			EPO; JPO;	
			DERWENT;	
			IBM TDB	
- [	75	heat\$4 near2 surround same susceptor	USPAT;	2002/12/06
		•	US-PGPUB;	13:42
1			EPO; JPO;	
			DERWENT;	
			IBM TDB	